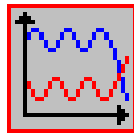


# **NKDGen**

## **Spectral properties of thin film stacks**



## **User Manual**

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## User Manual

*NKDGen* is a software application to generate spectrophotometric and ellipsometric spectra of a thin film stack defined by the user. Generated data can be any of the most common physical magnitudes measured in a thin films lab. The optical constants of the layers can be described through a wide range of models.

### **1. Introduction**

*NKDGen* calculates optical spectra of coated substrates for a wide range of data type and layer models. The classical electromagnetic theory of light propagation in thin film stacks [1] is used for the computations. The most important features of the software are:

- Simulation of spectrophotometric data for any angle of incidence. Reflectance, transmittance and backside reflectance, for s-, p- or natural incident light polarization can be calculated. The backside of the substrate can be taken into account by considering (single or multiple) incoherent internal substrate reflections.
- Ellipsometric data ( $\Delta, \Psi$ ) and related trigonometric quantities can be simulated to compare with the output of different ellipsometer types.
- Wide variety of dispersion models for the materials of the layers (suitable for dielectrics, metals, and semiconductors), as well as user-defined optical constants through a text file.
- Modelling of mixtures of materials by the Effective Medium Approximation (EMA) theory. Our software allows considering more than two materials in the mixtures [2]. Roughness and interfaces between layers are also modeled by EMA theory.
- Refractive index ( $n$ ) can have in-deep inhomogeneity, by dividing the layer in sublayers of equal thickness. The user can define a simple linear profile for  $n$ , a two-slope profile or a segmented profile.
- Different units (nanometer, eV, microns,  $\text{cm}^{-1}$ ) can be used.

### **2. General description**

The software consists of a standard Windows application, starting with a presentation box. Clicking on the *Start* button, the main window of *NKDGen* is shown (see Fig.1)

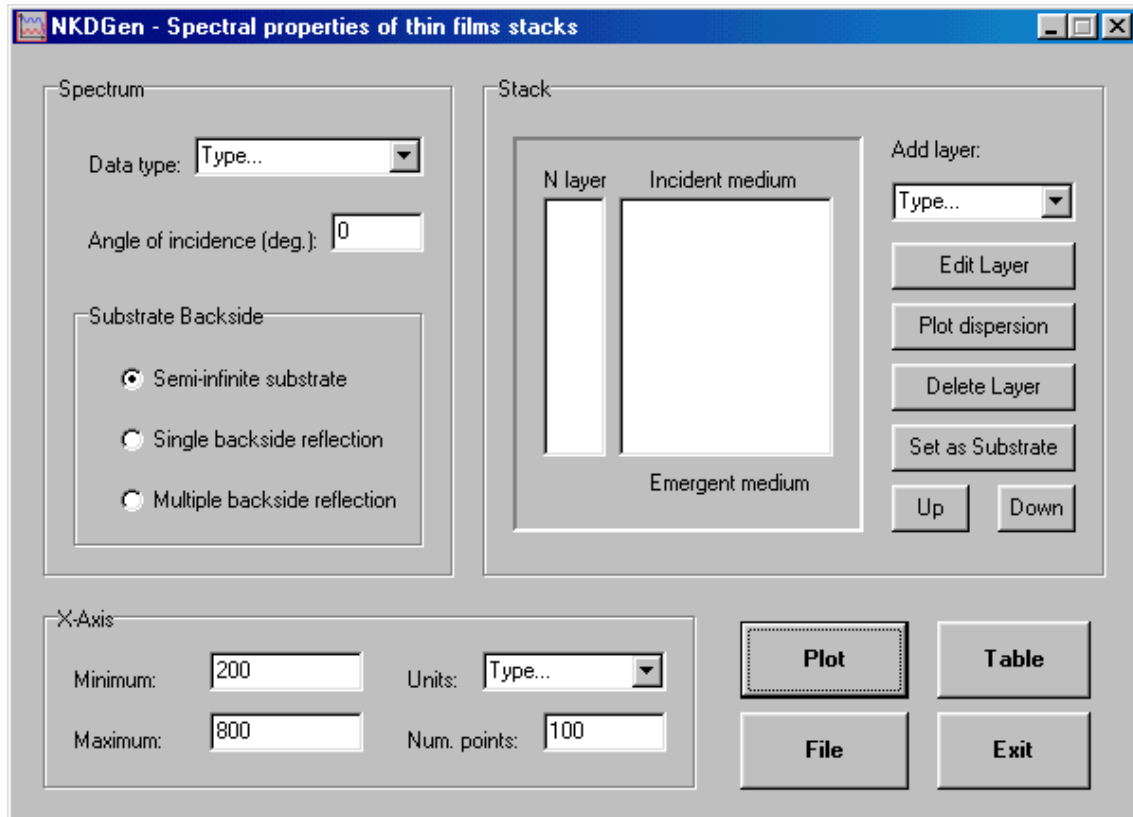


Fig. 1 –Main window of the application

The main window is divided in four different sections. The top left one (*Spectrum*) is for the definition of the physical magnitude to compute. The section *Stack* allows to define the sample. At the down-left corner, the section *X-Axis* is for defining the spectral range and units for the calculations. Buttons *Plot*, *Table* and *File* are for performing the calculations and show them as a graph (*Plot*), a table (*Table*) or save as a file (*File*). The *Exit* button finishes the application. Details about these sections are given in following paragraphs.

## **2.1 Spectrum**

The user can define here the physical magnitude to calculate. As mentioned above, spectrophotometric and ellipsometric data can be considered. All available options are listed in *Data Type*. For spectrophotometric data, the polarization state of the incident beam is indicated by *s-*, *p-* and *unpol.* (s-polarization, p-polarization and natural polarization). For ellipsometric data, several variations of the ellipsometric angles  $\Delta$  and  $\Psi$  are available. The field *Angle of incidence* allows setting the angle of incidence ( $\phi$  in degrees,  $0^\circ \leq \phi < 90^\circ$ ) of the light beam.

*Substrate backside* permits to choose how add internal reflections at the rear-side of the substrate. For rough or wedged rear-side substrates, the logical choice is ‘Semi-infinite substrate’ (no reflections). For well polished, parallel faced substrates, the effect of the rear-side will be added to the calculations incoherently [3]. The user can choose between taking into account only the first reflected beam (*Single backside reflection*) or all the multiple reflections (*Multiple backside reflection*).

**Remark:** Some restrictions apply for the *Data type*. For ellipsometric data the substrate is always considered as semi-infinite and the angle of incidence must not be zero. The user has to be careful with the multiple options offered by the program, in order to avoid meaningless optical data calculations. For instance, it is probably meaningless to consider multiple contributions from the backside when computing the reflectance at 45 deg. incidence angle for comparing with an experimental measurement, as these contribution will be lost by the detector.

## **2.2 Stack**

In this section the user defines the layers that configure the stack. At the left side the current structure of the coating is shown, with the layers numbered, from incident to emergent medium, as *1, 2...*, *S* (substrate), ... *2', 1'*. A maximum of 50 layers is permitted.

The right side has a set of buttons that allow manipulating layers. The options are: *Add Layer* (adding layers, selecting the model), *Edit layer* (editing the parameters of a selected layer (see below)), *Plot dispersion* (plotting the optical constants (*n* and *k*) of the highlighted layer in the range defined in *X-Axis*), *Delete layer* (deleting a selected layer), or *Set as substrate* (setting a selected layer as substrate). It is possible also to move the layer position in the stack with the *Up* and *Down* buttons.

The user has to note that some restrictions apply to the configuration of the stack. *Roughness* layers can only be placed in contact with the incident or emergent media. *Interfaces* can not be in contact with a *Roughness* layer (in fact, roughness is an interface between the material and air) or with another *Interface*. One layer must be defined as substrate, and it must be homogeneous. If any of these conditions is not met, when one tries to generate data, a message will notify the user which item is not correct.

## **2.3 X-Axis**

This is to define the range for the spectral calculations. *Minimum* and *maximum* indicate the limits, and *NumPoints* the number of points (equidistant) within the range (maximum *NumPoints* is 1000). The user must also define the *Units* of the spectra (nanometers, microns, eV or  $\text{cm}^{-1}$ ).

## **2.4 “Plot”, “Table” and “File” buttons**

All these buttons perform the calculation of the optical data selected in section *Spectrum*, of the currently defined *Stack*, in the range indicated in *X-Axis*. Calculations are presented in different forms. Pressing the button *Plot*, a 2-dimensional graph will appear showing the generated data. Pressing *Table*, the results will be shown as a table within a window. If ellipsometric data are generated, two graphs or two tables ( $\Delta/\Psi$ ) will show. These two kind of output are shown in Fig.2. If the button *File* is pressed, the data will be calculated and saved into a file in ASCII format.

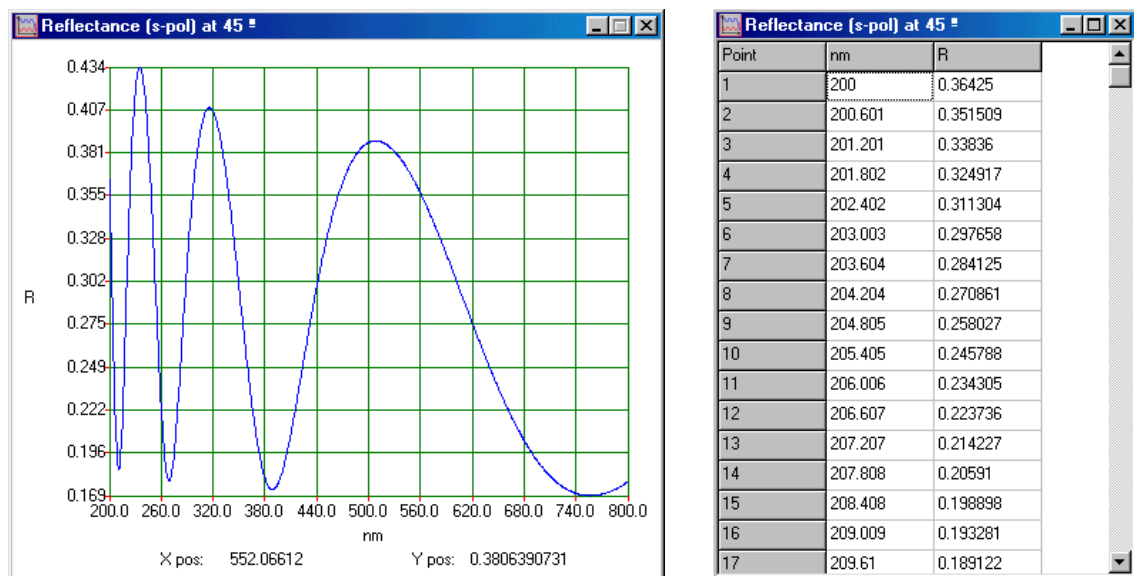


Fig. 2. Plot and Table: output of the program

### 3. Editing Layers

Editing layers is the way of setting the value of the parameters which define the optical properties of a layer (thickness, dispersion, volume fractions of component materials ...). The layer model can not be changed from this window, since it is assigned when the layer is added to the stack.

To edit one of the layers of the current stack, the layer must be highlighted and the button *Edit Layer* has to be pressed. A window (like in Fig. 3) will show, with different fields depending on the layer model.

Figure 3 shows the "Layer parameters: Tauc-Lorentz model" window. The window contains the following fields and options:

- Layer thickness: 0.2 microns
- Dispersion parameters:
  - E<sub>g</sub>: 1.2 eV
  - E<sub>o</sub>: 6.5 eV
  - A: 15 eV
  - C: 3 eV
  - E<sub>ps. inf</sub>: 1.5
- Inhomogeneity type:
  - ☒ Homogeneous
  - ☐ Linear
  - ☐ 2-Line
  - ☐ Segmented
- Buttons: "Show dispersive equations", "Edit inhomogeneity parameters", "Ok", and "Cancel".

Fig. 3- Layer Parameter window

The field *Layer thickness* allows the user to assign thickness (in microns) to the current layer. In the *Dispersion parameters* section, the user sets the values of the parameters describing the dispersion of the optical constants. The dispersive equations of the model can be displayed by pressing the button *Show dispersive equations*. Finally, the user can select the inhomogeneity profile of the real part of the refractive index in the *Inhomogeneity type* area, allowing to edit the corresponding parameters (described in section 4) for each inhomogeneity model in a new window.

In most of the cases the *Dispersion parameters* section is fixed, this means that a fixed number of parameter fields have to be filled. When the layer model is *EMA* or *Oscillators* the number of parameters can change (depending on the number of materials considered in the mixture or the number of oscillators, respectively), and the number of fields to fill change dynamically (when the number of materials or oscillators is changed).

In the case of the models that require input files containing optical constants of materials (*EMA* and *Material File* models), the files must have a special format. They must be in ASCII format and contain three columns: wavelength (in nm.), n and k. No header has to be written and separators between columns must be spaces or tabs. Several examples of material files are given in the file *materials.zip*.

Note that for EMA model, the sum of volume fractions of component materials is equal to 1. If this condition is not met, the volume fraction of last material ( $f_n$ ) component is ignored and set to  $f_n = 1 - \sum_{i=1..n-1} f_i$  automatically.

As mentioned, interfaces and roughness are modeled by EMA theory, describing respectively a mixture of three (2 adjacent layers and air) and two (adjacent layer and air) materials.

#### **4. Editing Inhomogeneity Layers**

Three different refractive index profiles can be applied to any layer. It must be noted that the refractive index profile affects only to the real part of the complex refractive index (n), and not to the extinction coefficient, which is considered constant in the whole layer. The inhomogeneity of a layer is modeled by dividing it into an odd number L of sublayers of equal thickness and establishing some kind of relation between the refractive index values of each sublayer. By pressing the button *Edit inhomogeneity parameters* of the layer parameters window described above, a new window shows, according to the inhomogeneity model selected. Fig. 4 shows the window for the case of a *Segmented* profile model:

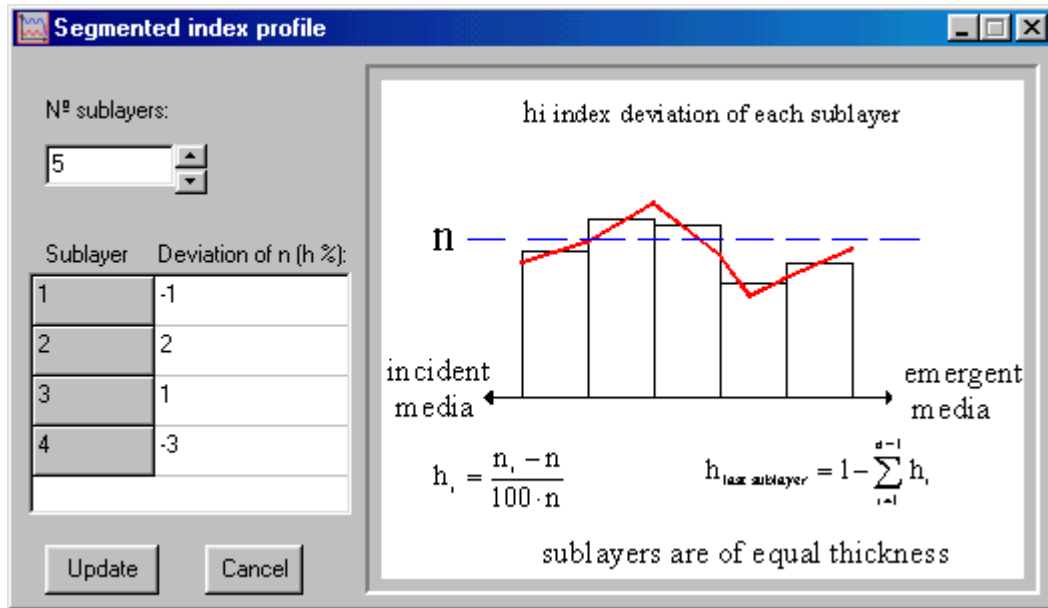


Fig.4- Edit inhomogeneity parameters window for a *segmented* profile

In these windows, a graph depicts the meaning of the required parameters and, at the left side, the required fields to input these parameters. The different inhomogeneity models that can be applied to a layer are:

- *Homogeneous* model: refractive index has a constant value in the whole layer.
- *Linear*: a linear in-depth variation of the refractive index is assumed; the slope of this linear variation is the characteristic parameter of this model.
- *2-Line*: refractive index varies according to two in-depth linear variations (one for the external sublayers and another for the internal ones; the two slopes are the parameters defining this case).
- *Segmented*: each sub-layer has an arbitrary deviation from the mean refractive index; the deviations of the sub-layers are not independent and, since the sum of all deviations must be zero, only L-1 parameters are independent.

In the case of *Interface* layers and when any of the adjacent layers is inhomogeneous, calculations will not take into account inhomogeneity degree. The same consideration is applied to *Roughness* layers.

## References

- [1] R.M.A.Azzam and N.M.Bashara, *Ellipsometry and Polarized Light*, North-Holland, Amsterdam, 1975
- [2] Salvador Bosch, Josep Ferré-Borrull, Norbert Leinfellner and Adolf Canillas, *Effective dielectric function of mixtures of three or more materials: a numerical procedure for computations*, Surface Science, Volume 453, Issues 1-3, 2000, Pages 9- 17.
- [3] H.A. McLeod, *Thin Film Optical Filters*. American-Elsevier, New York, 1969